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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: ARTELSMAIR - 6 PCT (RCE)  
SERIAL NO.: 10/574,401 EXAMINER: Hung D. NGUYEN  
FILED: APRIL 3, 2006 GROUP: 3742  
TITLE: METHOD FOR CONTROLLING AND/OR ADJUSTING A WELDING  
PROCESS AND WELDING DEVICE FOR CARRYING OUT A  
WELDING PROCESS

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Commissioner:

Supplemental to the Information Disclosure Statement filed on April 3, 2006 and Supplemental Information Disclosure Statement filed on February 25, 2008, Applicant wishes to bring to the attention of the Patent Examiner the references listed on the enclosed Form PTO-1449 and attached thereto. These references were cited in a Japanese Examination Report. A copy of the Japanese Examination Report is enclosed, along with an English translation of the Grounds of Rejection set forth therein.

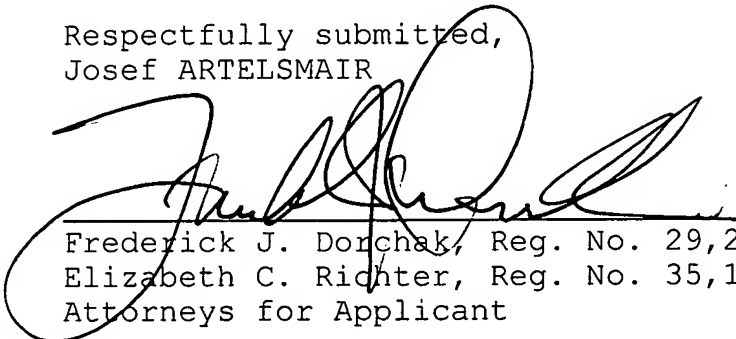
Because this Supplemental Information Disclosure Statement is being filed before a first Office Action on the merits in the

continued examination of the above-identified application, it is believed that no fee is required; however, if a fee should be required for this Second Supplemental Information Disclosure Statement, the Commissioner of Patents and Trademarks is hereby authorized to charge any required fee, or to credit any overpayment to Deposit Account No. 03-2468.

It is respectfully requested that the foregoing Second Supplemental Information Disclosure Statement be incorporated into the official file of the present patent application.

Respectfully submitted,  
Josef ARTELSMAIR

COLLARD & ROE, P.C.  
1077 Northern Boulevard  
Roslyn, New York 11576  
(516) 365-9802



Frederick J. Dorchak, Reg. No. 29,298  
Elizabeth C. Richter, Reg. No. 35,103  
Attorneys for Applicant

Enclosures:

PTO-form 1449 with two (2) references  
Japanese Examination Report with English translation of Grounds of Rejection

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 1, 2010.



Amy Klein